

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Serial No. : 10/712,495                      Group Art Unit: 1762  
Filed : November 13, 2003                  Inventor: Frank Jansen  
Attorney Docket : M02A430                  Examiner: Howard E. Abramowitz  
Title : ATOMIC LAYER DEPOSITION PROCESS AND APPARATUS

**MAIL STOP: Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450**

**RESPONSE**

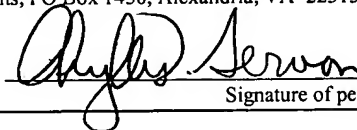
Sir:

In response to the Office Action dated June 21, 2005, please amend the application identified above as follows.

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: MAIL STOP: Amendment, Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450  
on: Sept 14, 2005

PHYLLIS SERVON  
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